

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Linyong Pang, et al.

Art Unit:

2825

Serial Number: 10/618,816

Examiner:

Vuthe Siek

Filing Date:

07/11/2003

Title "System And Method For Providing Defect Printability Analysis Of Photolithographic Masks

With Job-Based Automation"

Date: June 29, 2005

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

There is an error with respect to the following:

Error in

Correct data

Domestic Priority Data

which is a CIP of 09/130,996 8/7/1998 PAT 6,757,645

A copy of the Filing Receipt with the changes noted thereon is enclosed. Issuance of a corrected Filing Receipt is respectfully requested.

Respectfully submitted,

Dated: June 29, 2005

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I hereby certify that this correspondence is being deposited with the United States Postal Service as FIRST CLASS MAIL in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, on June 29, 2005.

Signature: Pulseca A Baumano



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CONFIRMATION NO. 5976

FILING RECEIPT

OC000000011023653

29477 NUMERICAL C/O BEVER HOFFMAN & HARMS, LLP 2099 GATEWAY PLACE **SUITE 320** SAN JOSE, CA 95110-1017

Date Mailed: 10/10/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Linyong Pang, Castro Valley, CA; Fang-Cheng Chang, Sunnyvale, CA; LOS ALTOS

Assignment For Published Patent Application

Numerical Technologies, Inc.;

Domestic Priority data as claimed by applicant

This application is a CIP of 10/372,066 02/20/2003 which is a DIV of 09/544,798 04/07/2000 PAT 6,578,188 which is a CIP of 09/154,397 09/16/1998 PAT 6,453,452 which_claims benefit of 60/059,306 09/17/1997

Which is A CIP OF 09/130,996 8/7/1998 PAT 6,757, 645 (*)Data provided by applicant is not consistent with PTO records.

Foreign Applications

If Required, Foreign Filing License Granted: 10/09/2003

Projected Publication Date: 01/22/2004

Non-Publication Request: No

Early Publication Request: No

Title

System and method for providing defect printability analysis of photolithographic masks with job-based automation

Preliminary Class

716

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